



Docket No: 05618.P3001

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Dagmar Bettina Beyerlein

Application No.: 10/029,608

Filing Date: December 20, 2001

For: CONTACT AND PENETRATION DEPTH  
SENSOR FOR A NEEDLE ASSEMBLY

)  
) Examiner: Mendez, Manuel A.

)  
) Art Unit: 3763

)  
) Confirmation No. 4535

)  
) Date of NOA: 03/09/2007

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

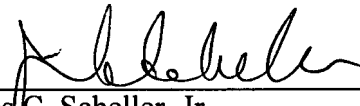
Dear Sir:

The Examiner's statement of reasons for allowance clearly has been directed to only certain claims and not all claims. Therefore, the Examiner's statement of reasons for allowance should be interpreted as applying to only those claims which include the language referred to by the Examiner in the statement. Furthermore, it is noted that the claim language should be viewed in light of the exact language of the claim rather than any paraphrasing thereof.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN

Date: 6/4, 2007

  
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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, PO Box 1450, Alexandria, Virginia 22313-1450

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